

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	12	(("6276214") or ("6315956") or ("6452564") or ("6,080,470") or ("5,352,493") or ("5,466,431")).PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/11/24 08:07
L2	1192	(resistivity near3 (test\$5 detect\$5 sens\$5 estimat\$5 evalut\$5 determin\$5 measur\$5 transducer cell meter gauge monitor\$5)).clm.	USPAT; EPO; JPO	OR	ON	2004/11/24 09:30
L3	25653	(resist\$7 near3 (test\$5 detect\$5 sens\$5 estimat\$5 evalut\$5 determin\$5 measur\$5 transducer cell meter gauge monitor\$5)).clm.	USPAT; EPO; JPO	OR	ON	2004/11/24 08:28
L4	187	3 near5 coating.clm.	USPAT; EPO; JPO	OR	ON	2004/11/24 08:28
L5	2087	3 near5 (layer film sheet coating).clm.	USPAT; EPO; JPO	OR	ON	2004/11/24 08:32
L6	19	5 and diamond\$9.clm.	USPAT; EPO; JPO	OR	ON	2004/11/24 08:32
L7	170	2 near5 (layer film sheet coating).clm.	USPAT; EPO; JPO	OR	ON	2004/11/24 08:32
L8	3	7 and diamond\$9.clm.	USPAT; EPO; JPO	OR	ON	2004/11/24 09:16
L9	0	7 and diamond-like	USPAT; EPO; JPO	OR	ON	2004/11/24 09:14
L10	0	7 and diamond near8 composite	USPAT; EPO; JPO	OR	ON	2004/11/24 08:33
L11	3782	"12" and diamond-like	USPAT; EPO; JPO	OR	ON	2004/11/24 09:14
L12	3	1 and diamond-like	USPAT; EPO; JPO	OR	ON	2004/11/24 09:16
L13	41	7 and carbon	USPAT; EPO; JPO	OR	ON	2004/11/24 09:16
L14	2	13 and diamond\$9	USPAT; EPO; JPO	OR	ON	2004/11/24 09:44
L15	41023	((layer coating thin film) near3 (test\$5 detect\$5 sens\$5 estimat\$5 evalut\$5 determin\$5 measur\$5 transducer cell meter gauge monitor\$5)).clm.	USPAT; EPO; JPO	OR	ON	2004/11/24 09:25
L16	2395	15 same ((layer coating thin film) near3 (conductive)).clm.	USPAT; EPO; JPO	OR	ON	2004/11/24 09:25
L17	340	16 same ((layer coating thin film) near3 (insulating)).clm.	USPAT; EPO; JPO	OR	ON	2004/11/24 09:26

L18	3	17 and diamond\$9.clm.	USPAT; EPO; JPO	OR	ON	2004/11/24 09:40
L19	8	(resistivity near3 (test\$5 detect\$5 sens\$5 estimat\$5 evalut\$5 determin\$5 measur\$5 transducer cell meter gauge monitor\$5) near4 (conductive near3 (caoting layer thin film))).clm.	USPAT; EPO; JPO	OR	ON	2004/11/24 09:45
L20	2	18 and resistivity	USPAT; EPO; JPO	OR	ON	2004/11/24 09:40
L21	0	19 and diamond\$9	USPAT; EPO; JPO	OR	ON	2004/11/24 09:49
L22	123	(resistivity near3 (test\$5 detect\$5 sens\$5 estimat\$5 evalut\$5 determin\$5 measur\$5 transducer cell meter gauge monitor\$5) near4 ((caoting layer thin film))). clm.	USPAT; EPO; JPO	OR	ON	2004/11/24 09:45
L23	6	22 and diamond\$9	USPAT; EPO; JPO	OR	ON	2004/11/24 09:49